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ETC 2800 MAIL ROOM

USA Patent Application

Jun Akedo

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ULTRA FINE PARTICLE FILM
FORMING METHOD AND APPARATUS

CERTIFICATE OF MAILING

Hon. Commissioner of Patents and Trademarks

Washington, D.C. 20231

S I R :

SECOND INFORMATION DISCLOSURE STATEMENT

Respectfully submitted herewith is a copy of an article "Jet molding system for realization of three-dimensional micro-structures" in order to meet the duty of disclosure. This document is in the English language so no further concise explanation is required to be pointed out. A PTO-1449 form is presented to list the submitted reference.

This submission meets the requirements of 37 CFR §1.56, 1.97 and 1.98(a) and MPEP 609.

Respectfully submitted,

Jun Akedo

by:

MARTIN A. FARBER
Attorney for Applicant
Registered Representative
Registration No. 22,345

CERTIFICATE OF MAILING UNDER 37 CFR SECTION 1.8(a)

I hereby certify that the accompanying Information Disclosure Statement, PTO-1449 form and 1 reference are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents & Trademarks, Washington, D.C. 20231, on April 25, 2001.

Dated: April 25, 2001

MARTIN A. FARBER

866 United Nations Plaza
New York, NY 10017
(212) 758-2878